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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO
DTJ		7-72256	03/17/95	JP	G01T	1/20	Abstract
BOJ		59-211263	11/30/84	JP	H01L	27/14	
BOJ		2-164067	06/25/90	JP	H01L	27/146	Abstract
BOJ		92/06501	04/16/92	WO	H01L	27/14	Abstract
BOJ		1-216290	08/30/89	JP	G01T	1/24	Abstract
BOJ		10-232824	09/02/98	JP	G06F	12/06	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

1373		Antonuk, L.E. et al, "Signal, Noise, and Readout Considerations in the Development of Amorphous Silicon Photodiode Arrays for Radiotherapy and Diagnostic X-ray Imaging", SPIE Vol. 1443, Medical Imaging V, Image Physics (1991), pp. 108-119
1373		Qureshi, S. et al, "Material Parameters in Thick Hydrogenated Amorphous Silicon Radiation Detectors", Lawrence Berkley Laboratory, University of California
1377		Naruse, Y., "Metal/Amorphous Silicon Multilayer Radiation Detectors", IEE Transactions on Nuclear Science, Vol. 36, No. 2, April 1989, pp. 1347-1352

EXAMINER

DATE CONSIDERED